Electronic Acknowledgement Receipt				
EFS ID:	2888145			
Application Number:	10816772			
International Application Number:				
Confirmation Number:	2790			
Title of Invention:	Methods of depositing an elemental silicon-comprising material over a semiconductor substrate and methods of cleaning an internal wall of a chamber			
First Named Inventor/Applicant Name:	Nirmal Ramaswamy			
Customer Number:	21567			
Filer:	Jennifer J. Taylor/Jaime White			
Filer Authorized By:	Jennifer J. Taylor			
Attorney Docket Number:	MI22-2520			
Receipt Date:	20-FEB-2008			
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Application Type:	Utility under 35 USC 111(a)			
Payment information:	1			
Submitted with Payment	yes			
Payment Type	Deposit Account			
Payment was successfully received in RAM	\$810			
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File Size(Bytes) Multi Pages /Message Digest Part /.zip (if appl.)

1	Request for Continued Examination (RCE)	rce22008.pdf	693598	no	3
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	Amendment Submitted/Entered with Filing of CPA/RCE		1	1	
	Specification		2	2	
	Claims		3	13	
	Applicant Arguments/Remarks Made in an Amendment		14	17	
Warnings:					
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3 Information Disclosure Statement	Information Disclosure Statement	idletter.pdf	16746	no	1
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Information:					
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5 Foreign Reference	do20712706 ndf	645386		14	
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If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

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If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/IDO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filling Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.